

Title (en)

Alarm and control system for semiconductor manufacturing plants.

Title (de)

Alarm- und Steuerungssystem einer Herstellungsanlage für Halbleiter.

Title (fr)

Système d'alarme et de commande pour installation de fabrication de semi-conducteurs.

Publication

**EP 0112491 A2 19840704 (EN)**

Application

**EP 83111571 A 19831119**

Priority

JP 20688982 A 19821127

Abstract (en)

This invention relates to an alarm and control system which detects leak of processing gas or a fire occurring in manufacturing process in very large-scale integrated circuit manufacturing plants, and adequately controls fire protection system such as fire extinguishing system and the manufacturing process.

IPC 1-7

**G08B 17/10**

IPC 8 full level

**G08B 17/00** (2006.01); **A62C 3/00** (2006.01); **G08B 17/117** (2006.01)

CPC (source: EP)

**G08B 17/117** (2013.01)

Designated contracting state (EPC)

BE CH DE FR GB IT LI

DOCDB simple family (publication)

**EP 0112491 A2 19840704**; **EP 0112491 A3 19870916**; **EP 0112491 B1 19900110**; DE 3381098 D1 19900215; ES 527815 A0 19850416; ES 8505124 A1 19850416; JP S5998294 A 19840606

DOCDB simple family (application)

**EP 83111571 A 19831119**; DE 3381098 T 19831119; ES 527815 A 19831125; JP 20688982 A 19821127